

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date July 27, 2006

In re the Application of

Masatake NAKANO

Group Art Unit: 2812

Application No.: 10/500,381

Examiner: S. ISAAC

Filed: June 29, 2004

Docket No.: 120164

For: METHOD OF PRODUCING SOI WAFER AND SOI WAFER

**LARGE ENTITY PETITION FOR 1<sup>st</sup> - 3<sup>rd</sup> EXTENSION  
OF TIME UNDER 37 C.F.R. §1.136(a) AND  
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

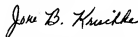
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a Request for Continued Examination in the above-identified patent application. The shortened statutory period having expired June 13, 2006, an extension of time for a period of two months is hereby requested.

The fees associated with this filing under 37 C.F.R. §1.136(a) are being paid electronically with this filing. The Commissioner is hereby authorized to charge any additional fee (or credit any overpayment) associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,



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**DEPOSIT ACCOUNT USE  
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Please grant any extension  
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